

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	6093468
<b>Application Number:</b>	10530612
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	6739
<b>Title of Invention:</b>	Plasma system and method for anisotropically etching structures into a substrate
<b>First Named Inventor/Applicant Name:</b>	Franz Laermer
<b>Customer Number:</b>	26646
<b>Filer:</b>	Gerard A. Messina/rita hannan
<b>Filer Authorized By:</b>	Gerard A. Messina
<b>Attorney Docket Number:</b>	10191/3964
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<b>Application Type:</b>	U.S. National Stage under 35 USC 371

### Payment information:

Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Transmittal Letter	slds.pdf	176457	no	2
			01c2566501b64994cac01f73059593cac d319		

### Warnings:

### Information:

2	Foreign Reference	jp2003246023.pdf	1381090 6590b4b65aa888c51cd8e917779c795b5c448a	no	10
Warnings:					
Information:					
3	Foreign Reference	jp2001127049.pdf	2393872 7386c991dc5d8cbed8b3b78a63718f921098c9	no	27
Warnings:					
Information:					
4	Foreign Reference	jp2000323454.pdf	1584293 1282716c5246d7d3714b2c5088c2d725c7a619a	no	20
Warnings:					
Information:					
5	Foreign Reference	jp5267226.pdf	1466223 780dc793a8817c5b88593c61803eed5dd30a05	no	12
Warnings:					
Information:					
6	Foreign Reference	jp10144654.pdf	5564867 6c3eede9b1a5853d51538e89c981188c77d6a8	no	64
Warnings:					
Information:					
7	Foreign Reference	de19736370.pdf	703788 6dc8f71a239a38d1e81e88278a2788199c2c0b	no	5
Warnings:					
Information:					
8	Foreign Reference	de19539078.pdf	986480 a18f9c7228288255c28182e527c21af4c2fdca8	no	11
Warnings:					
Information:					
9	Foreign Reference	jp6314600.pdf	2924468 77e83c3cb2d84e0081d827f25773269c79c3b7b	no	22
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**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

**New International Application Filed with the USPTO as a Receiving Office**

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.